



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 2779  
Hiromi OGASAWARA et al. : Docket No. 2003\_0912A  
Serial No. 10/616,996 : Group Art Unit 2813  
Filed July 11, 2003 : Examiner Jennifer M. Dolan

METHOD OF MANUFACTURING A  
SEMICONDUCTOR  
ELEMENT

---

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action dated August 11, 2004, the period for response to which having been extended by three-months to February 11, 2005, please amend the above-identified application as follows.